

## INFORMATION DISCLOSURE STATEMENT

Applicant : Basol et al.  
App. No : 10/782,697  
Filed : February 18, 2004  
For : METHOD OF WAFER PROCESSING  
WITH EDGE SEED LAYER  
REMOVAL  
Examiner : Michael Manh Trinh  
Art Unit : 2822  
Conf. No. : 5582

CERTIFICATE OF EFS WEB  
TRANSMISSION

I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

March 7, 2008

(Date)



Adam Gilbert, Reg. No. 59,967

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:


Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 4 references to be considered by the Examiner. Also enclosed is 1 foreign patent reference and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 3/7/08

By:   
Adam Gilbert  
Registration No. 59,967  
Attorney of Record  
Customer No. 20,995  
(949) 760-0404